

<b>Notice of References Cited</b>	Application/Control No. 10/758,286		Applicant(s)/Patent Under Reexamination MOCHIZUKI, FUMIHIKO	
	Examiner Jennifer M. Dolan		Art Unit 2813	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,978,408	11-1999	Thornton, Robert L.	372/96
*	B	US-2001/0048118	12-2001	Uchida et al.	257/190
*	C	US-6,327,071	12-2001	Kimura, Koichi	359/291
*	D	US-6,324,192	11-2001	Tayebati, Parviz	372/20
*	E	US-2003/0116711	06-2003	Hara et al.	250/338.1
*	F	US-5,291,502	03-1994	Pezeshki et al.	372/20
*	G	US-2002/0154675	10-2002	Deng et al.	372/96
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	M. C. Larson et al., "Vertical Coupled-Cavity Microinterferometer on GaAs with Deformable-Membrane Top Mirror," IEEE Photonics Technology Letters, Volume 7, No. 4, April 1995.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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